

*IN THE UNITED STATES PATENT AND TRADEMARK OFFICE*

In re PATENT APPLICATION of :

Paul RICH et al. :

Serial No. [NEW] :

Filed: January 21, 2004 :

For: ELECTROSTATIC CLAMPING OF THIN WAFERS IN PLASMA  
PROCESSING VACUUM CHAMBER

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**PRELIMINARY AMENDMENT**

U.S. Patent and Trademark Office  
2011 South Clark Place  
Customer Window, **Mail Stop Patent Application**  
Crystal Plaza Two, Lobby, Room 1B03  
Arlington, VA 22202

Sir:

Preliminary to the examination of the above-identified application,  
please amend the above-identified application as follows:

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which  
begins on page 3 of this paper.

**Remarks** begin on page 5 of this paper.